The by certify that on the date specified below, this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to the Commissioner for Parints, Washington, DC 20231.

January 16, 2002

Date Rena Iov

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**Applicants** 

Ulrich C. Boettiger and Scott L. Light

Application No.

09/945,316

Confirmation No.: 1351

Filed

August 30, 2001

For

METHOD AND APPARATUS FOR CONTROLLING RADIATION

BEAM INTENSITY DIRECTED TO MICROLITHOGRAPHIC

**SUBSTRATES** 

Art Unit

1756

Docket No.

108298547US

Date

January 16, 2002

Commissioner for Patents Washington, DC 20231

## PETITION FOR EXTENSION OF TIME UNDER 37 CFR. § 1.136(a)

Sir:

Applicants herewith petition the Commissioner of Patents under 37 CFR § 1.136(a) for a one-month extension of time for filing the response to the Examiner's Action dated October 16, 2001, from December 16, 2001, to January 16, 2002, and enclose the amount of \$110.00 for the requisite fee. Any deficiency or overpayment should be charged or credited to Deposit Account No. 50-0665. This petition is being submitted in triplicate.

Respectfully submitted,

Perkins Coie LLP

John M. Wechkin

Registration No. 42,216

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